

SEP 27 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No. 10/720,231
Confirmation No. 4341
Filing Date November 25, 2003
Inventor Wei Guo et al.
Assignee Honeywell International Inc.
Group Art Unit 1742
Examiner Unknown
Attorney Docket No. HO004345 (4016) / HO58-108
Title: High Purity Nickel/Vanadium Sputtering Components; and Methods of Making
Sputtering Components

Art Unit 1742
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Inventor: **Wei Guo et al.**Title: **High Purity Nickel/Vanadium Sputtering Components; and
Methods of Making Sputtering Components**Assignee: **Honeywell International Inc.**Docket No. **HO004345 (4016) / HO58-108**Serial No.: **10/720,231**Filed: **November 25, 2003****SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT****References – See Attached Form PTO-1449**

The attached form PTO-1449 is submitted in compliance with 37 CFR § 1.56. Copies of the cited art are included with the exception of U.S. patents and published U.S. applications (1273 Off. Gaz. Pat. Off. 55, 05 August 2003). No admission is made regarding whether the submitted reference is prior art.

Respectfully submitted,

Dated: 9/27/04By: David G. Katwesen, Ph.D.
Reg. No. 38,533

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. H0004345 (4016) / H035108		SERIAL NO. 10720231	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Wei Guo et al.		FILING DATE November 25, 2003	
				GROUP 1742			
U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	6,392,114 B1	01/02	Lam et al.			
	AB						
	AC						
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	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
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FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes No
	AM						
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OTHER REFERENCES (including Author, Title, Date, Patent Pages, Etc.)							
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